

Application/Control No.	Applicant(s)/Patent under Reexamination
10/618,399	LIN ET AL.
Examiner	Art Unit
Phuong T. Vu	2841

	SEARCHED				
Class	Subclass	Date	Examiner		
361	212 220 728	9/7/04	PIVU		
	752 796				
	818				
174	35R 3560 40	9/2/04	Mu		
	51	1 1			
2(1	71.17	9/7/01	Mu		
3/2	223.2	9/2/01	Jun		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
361	8/6	4/20/05	Pth		
,	818	, ,			
174	3 <del>4</del> 2	4/20/05			
	50	, ,			

(INCLUDING SEARCH STRATEGY)			
		DATE	EXMR
	:		
		<u> </u>	
			,